

Electronic Patent Application Fee Transmittal

Application Number:	10724750
Filing Date:	02-Dec-2003
Title of Invention:	METHOD FOR INSPECTING DEFECT AND APPARATUS FOR INSPECTING DEFECT
First Named Inventor/Applicant Name:	Akira Hamamatsu
Filer:	Melvin Kraus/Ricardo Perez
Attorney Docket Number:	520.43302PX1

Filed as Large Entity

Utility Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Basic Filing:

Pages:

Claims:

Miscellaneous-Filing:

Petition:

Patent-Appeals-and-Interference:

Post-Allowance-and-Post-Issuance:

Utility Appl Issue fee	1501	1	1400	1400
Publ. Fee- early, voluntary, or normal	1504	1	300	300

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Printed copy of patent - no color	8001	4	3	12
Total in USD (\$)				1712